

Appl. No. 09/754,264  
Amendment and/or Response  
Reply to Office Action of November 19, 2004

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IN THE UNITED STATES  
PATENT AND TRADEMARK OFFICE

Appl. No.: 09/754,264

Applicant(s): Tetsuo Usami, et al.

Filed: January 5, 2001

TC/A.U.: 2800/2814

Examiner: S.H. Rao

Atty. Docket: OK1.202

Title: Deposition Method For Wiring

Thin Film

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On: March 19, 2004

By: 

William S. Francos

AMENDMENT and/or RESPONSE under 37 C.F.R. § 1.111

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of November 19, 2003, please amend the  
above referenced application as follows and reconsider the application in light of the  
following remarks.

04/27/2004 TSTPTOE 00000001 500238 09754264

01 FC:1251 110.00 DA

Atty. Docket No. OK1.202

PAGE 1/8 \* RCVD AT 3/19/2004 6:31:56 PM [Eastern Standard Time] \* SVR:USPTO-EFAX-1/0 \* DNS:8729306 \* CSID:6103758380 \* DURATION (mm-ss):02-16